

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**priority** Application Serial No. .... 10/243,180  
**priority** Confirmation No. .... 4455  
**priority** Filing Date ..... 9/12/02  
Inventor..... A. Bhattacharyya  
Assignee ..... Micron Technology, Inc.  
**priority** Group Art Unit..... 2818  
**priority** Examiner ..... L. K. Tran  
Attorney's Docket No. .... MI22-2362  
Customer No. .... 021567  
Title: Methods of Making Semiconductor-on-Insulator Thin Film Transistor Constructions

**PRELIMINARY AMENDMENT**

To: Commissioner for Patents  
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**AMENDMENTS**

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